

	Application No.	Applicant(s)	
Notice of Allowability Ex	10/785.054	SONG ET AL.	
	Examiner	Art Unit	
	Thomas L. Dickey	2826	
The MAILING DATE of this communication applications being allowable, PROSECUTION ON THE MERITS IS rewith (or previously mailed), a Notice of Allowance (PTOL-85 DTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT IS the Office or upon petition by the applicant. See 37 CFR 1.31	S (OR REMAINS) CLOSED in 5) or other appropriate commu RIGHTS. This application is s	this application. If not included nication will be mailed in due cours	
☐ This communication is responsive to <u>Response after Ex I</u>	Parte Quayle Action filed 02-0	<u>7/06</u> .	
The allowed claim(s) is/are 1.3-5.10 and 12-16.			
a) ☑ Acknowledgment is made of a claim for foreign priority of a) ☑ All b) ☐ Some* c) ☐ None of the: 1. ☑ Certified copies of the priority documents have		r (f).	
2. Certified copies of the priority documents have	• • •		
Copies of the certified copies of the priority d	locuments have been received	in this national stage application fr	om the
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE noted below. Failure to timely comply will result in ABANDON THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		a reply complying with the requiren	nents
. A SUBSTITUTE OATH OR DECLARATION must be sub- INFORMAL PATENT APPLICATION (PTO-152) which gi			E OF
CORRECTED DRAWINGS (as "replacement sheets") mu	ust be submitted.		
(a) ☐ including changes required by the Notice of Draftspe	-	(PTO-948) attached	
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date	_·		
(b) ☐ including changes required by the attached Examine Paper No./Mail Date			
Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in) of
. DEPOSIT OF and/or INFORMATION about the dep attached Examiner's comment regarding REQUIREMENT	OSIT OF BIOLOGICAL MATE	RIAL must be submitted. Note the LOGICAL MATERIAL.	he
ttachment(s) . ☑ Notice of References Cited (PTO-892)	5. ☐ Notice of Inf	ormal Patent Application (PTO-152)
☐ Notice of Draftperson's Patent Drawing Review (PTO-948)		mmary (PTO-413),	,
☐ Information Disclosure Statements (PTO-1449 or PTO/SB	Paper No./I	Mail Date Amendment/Comment	
Paper No./Mail Date Examiner's Comment Regarding Requirement for Deposit	8 🕅 Evaminer's	Statement of Reasons for Allowance	A
of Biological Material			•
of Biological Material	9. 🗌 Other		

Page 2

Application/Control Number: 10/785,054

Art Unit: 2826

REASONS FOR ALLOWANCE

1. The following is an examiner's statement of reasons for allowance:

Claims 1, 3-5, 10, and 12-16 are allowed over the references of record because none of these references disclosed or can be combined to yield the claimed invention such as a semiconductor laser, comprising a substrate etched into a mesa structure; an active layer formed on the mesa structure and being a core of a waveguide; a first clad layer formed on the active layer; a current blocking layer formed on the etched substrate in both sides of the mesa structure; an etch-stop layer formed on the first clad layer and the current blocking layer; a second clad layer formed on the etch-stop layer being located on an upper portion of the mesa structure with a predetermined width; an ohmic contact layer formed on the second clad layer; a first electrode contacted with the ohmic contact layer; and a second electrode formed on the bottom of the substrate, wherein the current blocking layer is (applicant's claims, as of 12/18/05, recite, "may be," however the intended meaning appears to be "is") formed by a first p type, an n type, and a second p type semiconductor layers, as recited in claims 1, 10 and 14.

For example, KISH ET AL. 2005/0151144 discloses a semiconductor laser, comprising a substrate 12-13-14A etched into a mesa structure 28A; an active layer 16 formed on the mesa structure 28A and being a core of a waveguide 10N; a first clad layer 18A formed on the active layer 16; a current blocking layer 77 formed on the etched sub-

Application/Control Number: 10/785,054

Art Unit: 2826

strate 12-13-14A in both sides of the mesa structure 28A; an etch-stop layer 70-72 formed on the first clad layer 18A (part 70 is the part of etch stop layer 70-72 on first clad layer 18A) and the current blocking layer 77 (part 72 is the part of etch stop layer 70-72 on current blocking layer 77); a second clad layer 74 formed on the etch-stop layer 70-72 being located on an upper portion of the mesa structure 28A with a predetermined width; an ohmic contact layer 76 formed on the second clad layer 74; a first electrode 22 (seen in figure 1) contacted with the ohmic contact layer 76; a second electrode 26 (seen in figure 1) formed on the bottom of the substrate 12-13-14A. Kish et al. further discloses that the current blocking layer may be formed by a first p type semiconductor layer. But Kish et al. neither discloses nor suggests a current blocking layer formed by a first p type, an n type, and a second p type semiconductor layers, as recited in claims 1, 10, and 14.

For another example, MORI ET AL. 5,311,534 discloses a semiconductor laser, comprising a substrate 506; an active layer 501 formed directly on the substrate 506 and being a core of a waveguide; a first clad layer 504 formed on the active layer 501; a current blocking layer 507 formed from a first p type, an n type, and a second p type semiconductor layers, on the etched substrate 506 in both sides of the mesa structure; an etch-stop layer 503; a second clad layer 508 formed on the etch-stop layer 503 being located on an upper portion of the mesa structure with a predetermined width; an ohmic contact layer 509 formed on the second clad layer 508; a first electrode 510 contacted

Application/Control Number: 10/785,054

Art Unit: 2826

with the ohmic contact layer 509; and a second electrode 511 formed on the bottom of the substrate 506. However, Mori et al's etch-stop layer 503 is not formed on first clad layer 504 and current blocking layer 507, and a fundamental purpose of Mori et al's invention would no longer be served were etch-stop layer 503 to be moved so that it lay on first clad layer 504 and current blocking layer 507.

Ashida 5,949,809 provides further insight into the differences between the claimed semiconductor laser and semiconductor lasers disclosed in the prior art. Ashida discloses a semiconductor laser, comprising a substrate 1-2; an active layer 3 formed directly on the substrate 1-2 and being a core of a waveguide; a first clad layer 4a formed on the active layer 3; a current blocking layer 6 formed by a first p type 6a, an n type 7, and a second p type 6b semiconductor layers, a second clad layer 4b formed on the etch-stop layer being located on an upper portion of the mesa structure with a predetermined width; and an ohmic contact layer 9 formed on the second clad layer 4b. In the embodiment of figure 1 Ashida discloses an etch-stop layer 8 formed on the first clad layer 4a and the current blocking layer 6, and in the embodiment of figure 3 Ashida discloses that the second clad layer 4b is formed on a mesa structure with a predetermined width. But Ashida neither discloses nor suggests that the substrate is etched into a mesa structure or that the current blocking layer is formed on the etched substrate in both sides of said mesa structure.

Application/Control Number: 10/785,054 Page 5

Art Unit: 2826

Ultimately, it is the <u>incorporation</u> of a current blocking layer, formed by a first p type, an n type, and a second p type semiconductor layers, into a semiconductor laser, having an etch-stop layer formed on a first clad layer as well as being formed on said p-n-p current blocking layer that in turn is formed on both sides of a mesa structure etched from substrate, that renders the claimed invention novel and non-obvious.

2. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

3. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thomas L Dickey whose telephone number is 571-272-1913. The examiner can normally be reached on Monday-Thursday 8-6.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nathan J Flynn can be reached on 571-272-1915. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published appli-

Application/Control Number: 10/785,054 Page 6

Art Unit: 2826

cations may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Thomas L. Dickey Patent Examiner Art Unit 2826 02/06